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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/696,151	10/29/2003	Kangguo Cheng	FIS920030311US1	5490	
7590 09/28/2004		EXAMINER			
H. Daniel Schnurmann			LANDAU, MATTHEW C		
IBM Corporation					
Dept. 18G, Building 300-482			ART UNIT	PAPER NUMBER	
2070 Route 52			2815		
Hopewell Junction, NY 12533		·	DATE MAILED: 09/28/2004	DATE MAILED: 09/28/2004	

Please find below and/or attached an Office communication concerning this application or proceeding.

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	Application No.	Applicant(s)	
	10/696,151	CHENG ET AL.	
Office Action Summary	Examiner	Art Unit	
	Matthew Landau	2815	
The MAILING DATE of this communication Period for Reply	n appears on the cover sheet wi	th the correspondence address	
A SHORTENED STATUTORY PERIOD FOR R THE MAILING DATE OF THIS COMMUNICAT - Extensions of time may be available under the provisions of 37 C after SIX (6) MONTHS from the mailing date of this communicati - If the period for reply specified above is less than thirty (30) days - If NO period for reply is specified above, the maximum statutory - Failure to reply within the set or extended period for reply will, by Any reply received by the Office later than three months after the earned patent term adjustment. See 37 CFR 1.704(b).	ON. FR 1.136(a). In no event, however, may a roon. , a reply within the statutory minimum of thirt period will apply and will expire SIX (6) MON statute, cause the application to become AB	eply be timely filed y (30) days will be considered timely. THS from the mailing date of this communication. ANDONED (35 U.S.C. § 133).	
Status			
1) Responsive to communication(s) filed on	· · · · · · · · · · · · · · · · · · ·		
2a) ☐ This action is FINAL . 2b) ☐	This action is non-final.		
3) Since this application is in condition for all closed in accordance with the practice un	•	• •	
Disposition of Claims			
4) ⊠ Claim(s) <u>1-20</u> is/are pending in the application 4a) Of the above claim(s) is/are with 5) ☐ Claim(s) is/are allowed. 6) ⊠ Claim(s) <u>1-20</u> is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and applications.	hdrawn from consideration.		
Application Papers			
9) ☐ The specification is objected to by the Exa 10) ☑ The drawing(s) filed on 29 October 2003 i Applicant may not request that any objection to Replacement drawing sheet(s) including the color of	s/are: a)⊠ accepted or b)⊡ o to the drawing(s) be held in abeyar correction is required if the drawing	ce. See 37 CFR 1.85(a). s) is objected to. See 37 CFR 1.121(d).	
Priority under 35 U.S.C. § 119			
12) Acknowledgment is made of a claim for for a) All b) Some * c) None of: 1. Certified copies of the priority docu 2. Certified copies of the priority docu 3. Copies of the certified copies of the application from the International B * See the attached detailed Office action for	ments have been received. ments have been received in A e priority documents have been sureau (PCT Rule 17.2(a)).	pplication No received in this National Stage	
Attachment(s)	_		
 Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-94) 		ummary (PTO-413) s)/Mail Date	
 Notice of Dransperson's Patent Drawing Review (PTO-94) Information Disclosure Statement(s) (PTO-1449 or PTO/94) Paper No(s)/Mail Date 4/5/2004. 	· · · · · · · · · · · · · · · · · · ·	formal Patent Application (PTO-152)	

DETAILED ACTION

Claim Objections

Claims 11 and 15 are objected to because of the following informalities:

Regarding claim 11, the limitation "the strap is has" should be changed to read, "the strap [[is]] has".

Regarding claim 15, there is insufficient antecedent basis for the limitation "the node poly element". Appropriate correction is required.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 1-20 are rejected under 35 U.S.C. 102(b) as being anticipated by Mandelman et al. (US Pat. 2002/0105019, hereinafter Mandelman).

Regarding claims 1-3, Figure 6C and 6M of Mandelman disclose a DRAM cell comprising: a semiconductor substrate 10; a trench 16 extending into the substrate; a cell capacitor disposed in a bottom portion of the trench (paragraph [0051]); a cell transistor 24/32/36 disposed in a top portion of the trench above the cell capacitor; a node conducting element (upper portion of 22) connecting the cell capacitor to the cell transistor; and a collar 18 disposed about the node conducting element between the cell transistor and the cell capacitor; wherein: the

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collar is disposed in the substrate, wholly outside of the trench, between the cell capacitor and the cell transistor.

Regarding claims 4 and 5, Figure 6M of Mandelman discloses a strap 26 disposed between the node conducting element and the cell transistor, which is self-aligned with the collar.

Regarding claim 6, Figure 6M of Mandelman discloses a strap 26 disposed in the trench at substantially the same depth as the collar. Note that the strap and collar 18 are in contact. Therefore, at least the contact portions are at the same depth, and the two elements can be considered to be at substantially the same depth.

Regarding claims 7, 8, 11, and 20, Figures 6M of Mandelman discloses a strap 26 disposed in the trench and having a periphery; and the collar 18 is laterally adjacent and surrounds the periphery of the buried strap. As shown in Figures 6M and Figure 2 (showing the out-diffused region 24 which corresponds to the strap), the strap is formed on only one side of the trench, in an upper portion of the collar (see also paragraph [0054]), extending around the circumference of the trench. Therefore, it can be considered that the collar is laterally adjacent and surrounds the periphery of the buried strap, wherein the lateral direction is the direction around the circumference of the cylindrical trench.

Regarding claim 9, Figures 6C and 6M of Mandelman disclose a DRAM cell comprising: a semiconductor substrate 10; a trench 16 extending into the substrate; a cell capacitor disposed in a bottom portion of the trench (paragraph [0051]); a cell transistor 24/32/36 disposed in a top portion of the trench above the cell capacitor; a node conducting element (upper portion of 22) connecting the cell capacitor to the cell transistor; and a collar 18 disposed about the node

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conducting element between the cell transistor and the cell capacitor; and a strap 26; wherein the strap is embedded into a top surface of the collar (paragraph [0054]).

Regarding claim 10, Figure 6M of Mandelman discloses the strap extends no higher than the collar.

Regarding claims 12-14, Figures 6A-6M of Mandelman disclose a method of forming DRAM cells, comprising: forming trenches 16 in a semiconductor substrate 10; forming cell capacitors in a bottom portion of the trench (paragraph [0051]); forming cell transistors 24/32/36 in a top portion of the trench; and for each DRAM cell, providing a collar 18 between the cell capacitor and the cell transistor, the collar being disposed in the substrate, wholly outside of the trench.

Regarding claims 15 and 16, Figures 6A-6M of Mandelman disclose for each DRAM cell, providing a node conducting element (upper portion of 22) between the cell capacitor and the cell transistor; wherein: the collar is disposed laterally adjacent and laterally surrounds the node poly element.

Regarding claims 17 and 18, Figures 6A-6M of Mandelman disclose for each DRAM cell, providing a node conducting element (upper portion of 22) between the cell capacitor and the cell transistor; and a strap 26 disposed between the node conducting element and the cell transistor, wherein the strap is self-aligned with the collar.

Regarding claim 19, Figures 6A-6M of Mandelman disclose a providing strap 26 disposed in the trench at substantially the same depth as the collar. Note that the strap and collar 18 are in contact. Therefore, at least the contact portions are at the same depth, and the two elements can be considered to be at substantially the same depth.

Claim Rejections - 35 USC § 103

Claims 1-9 and 11-20 rejected under 35 U.S.C. 102(a) as anticipated by Tews et al. (US Pat. 6,599,798, hereinafter Tews) or, in the alternative, under 35 U.S.C. 103(a) as obvious over Tews in view of the admitted prior art.

Regarding claims 1-3 and 12-14, Figure 12 of Tews discloses a DRAM cell comprising: a semiconductor substrate; a trench extending into the substrate; a cell capacitor disposed in a bottom portion of the trench; a cell transistor (col. 5, lines 20-22) disposed in a top portion of the trench above the cell capacitor; a node conducting element (poly in trench, col. 5, lines 3-6); and a collar disposed about the node conducting element (col. 5, lines 5-7); wherein: the collar is disposed in the substrate, wholly outside of the trench, between the cell capacitor and the cell transistor. Tews discloses a vertical transistor is formed after the structure of Fig. 12 is completed (col. 5, lines 20-22). Therefore, it is believed that the node conducting element will connect the cell capacitor to the cell transistor through outdiffusion region 30 (which forms the source/drain of the transistor). If for some reason this is found to not be inherent, it would certainly be obvious to have the node conducting element connecting the cell capacitor to the cell transistor as shown in Figure 1 of the instant application (prior art) for the purpose of fabricating a functional DRAM device. Regarding claims 12-14, Figures 2-12 also disclose a method of making the device.

Regarding claims 4, 5, and 18, Figure 12 of Tews discloses a strap 28 disposed between the node conducting element and the cell transistor, wherein the strap is self-aligned with the collar.

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Regarding claims 6 and 19, Figure 12 of Tews discloses a strap 28 disposed in the trench at substantially the same depth as the collar.

Regarding claims 7 and 20, Figure 12 of Tews discloses a strap 28 disposed in the trench and laterally surrounded by the collar.

Regarding claim 8, Figure 12 of Tews discloses a strap 28 disposed in the trench and having a periphery; and the collar is laterally adjacent and surrounds the periphery of the buried strap.

Regarding claim 9, Figure 12 of Tews discloses a DRAM cell comprising: a semiconductor substrate; a trench extending into the substrate; a cell capacitor disposed in a bottom portion of the trench; a cell transistor (col. 5, lines 20-22) disposed in a top portion of the trench above the cell capacitor; a node conducting element (poly in trench, col. 5, lines 3-6); and a collar disposed about the node conducting element (col. 5, lines 5-7); a strap 28; wherein: the strap is embedded into a top surface of the collar. Tews discloses a vertical transistor is formed after the structure of Fig. 12 is completed (col. 5, lines 20-22). Therefore, it is believed that the node conducting element will connect the cell capacitor to the cell transistor through outdiffusion region 30 (which forms the source/drain of the transistor). If for some reason this is found to not be inherent, it would certainly be obvious to have the node conducting element connecting the cell capacitor to the cell transistor as shown in Figure 1 of the instant application (prior art) for the purpose of fabricating a functional DRAM device.

Regarding claim 11, Figure 12 of Tews discloses the strap has a periphery, which is laterally surrounded by the collar.

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Regarding claims 15 and 16, Figure 12 of Tews discloses a node conducting element

between the cell capacitor and the cell transistor; wherein: the collar is disposed laterally

adjacent to and surrounds a periphery of the node poly element.

Regarding claim 17, Figure 12 of Tews discloses a strap 28 between the node conducting

element and the cell transistor.

Conclusion

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Matthew C. Landau whose telephone number is (571) 272-1731.

The examiner can normally be reached from 8:30 AM - 5:30 PM. If attempts to reach the

examiner by telephone are unsuccessful, the examiner's supervisor, Tom Thomas can be reached

on (571) 272-1664. The fax phone numbers for the organization where this application or

proceeding is assigned are (703) 872-9306 for regular communications and (703) 872-9306 for

After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding

should be directed to the receptionist whose telephone number is (703) 308-0956.

SUPERVISORY PATER TO

TECHNOLOGY

Matthew C. Landau

Examiner

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September 26, 2004